FORM PTO-1986 RE 05-06-	Patent and Trademark Office
Teh cations d d d V	** ***** ***** ***** ***** **** **** ****
To the Honorable Commissioner of Patents and 102079	9283atached original documents or copy thereof.
1. Name of conveying party(les):	2. Name and address of receiving party(les):
Jiong Chen and Zhiming Wan	Name: Advanced Ion Beam Technology, I
	Internal Address:
04/26/06	a = =0
Additional name(s) of conveying party(les) attached?   Yes   No	9
3. Nature of conveyance:	
☑ Assignment ☐ Merger	Street Address: 116 South Wolfe Road
_	
☐ Security Agreement ☐ Change of Name	0.1005
Other	City: Sunnyvale State: CA ZIP: 94086
Execution Date: April 22, 2002	Additional name(s) & address(es) attached? 🖸 Yes 🔻 🔯 No
A. Patent Application No.(s)  Additional numbers att  5. Name and address of party to whom correspondence	B. Patent No.(s)    Cached?
concerning document should be mailed:  Name: Bo-In Lin	o. Total harber of applications and paterns involved. One
Internal Address:	7. Total fee (37 CFR 3.41):\$ 40.00
	☑ Enclosed
	Authorized to be charged to deposit account
Street Address: 13445 Mandoli Drive	8. Deposit account number:
Obulos Altos Hills out CA 715, 94022	(Attach duplicate copy of this page if paying by deposit accour
City: Los Altos Hills State: CA ZIP: 94022  DO NOT US	E THIS SPACE
05/06/2002 4AHMED1 00000073 10133140 01 FC:581 40.00 0P	
9. Statement and signature.	rmation is true and correct and any attached copy is a true copy  Signature  Total number of pages comprising cover sheet
	DATENIT

REEL: 012845 FRAME: 0959

Docket No.AIBT-2K10

## ASSIGNMENT

INVENTOR

Whereas, I, Jiong Chen of 1069 Oaktree Drive, San Jose,

AND CITY

California 95129

have invented:

TITLE:

APPARATUS FOR ION BEAM IMPLANTATION

DATE INVENTOR and executed a United States patent application therefor

SIGNED THE DECLARATION

on April 22 2002;

Whereas, ADVANCED ION BEAM TECHNOLOGY, INC., having a place of business at Sunnyvale, California, United States of America, (hereinafter called AIBT), desires to acquire the entire right, title and interest of said application and invention, and to any United States and foreign patents to be obtained therefor;

Now therefore, for a valuable consideration, receipt whereof is hereby acknowledged, I, the above named, hereby sell, assign, and transfer to AIBT, its successors and assigns, the entire right, title and interest in the said application and invention therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing said United States application, and I request the Commissioner of Patents to issue any Letters Patent granted upon the inventions set forth in said application to AIBT its successors and assigns; and I hereby agree that AIBT may apply for foreign Letters Patent on said invention and I will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by

CITY AND DATE

Signed and Sealed at 116 S. Wolfe Road, Sunnyvale, on April 22, 2002.

SIGNATURE OF INVENTOR

Docket No.AIBT-2K10

## ASSIGNMENT

INVENTOR AND CITY Whereas, I, Zhimin Wan of 366 South Mary Avenue, Sunnyvale,

California 94086

have invented:

TITLE:

APPARATUS FOR ION BEAM IMPLANTATION

DATE INVENTOR SIGNED THE DECLARATION

DATE INVENTOR and executed a United States patent application therefor

on April 22, 2002;

Whereas, ADVANCED ION BEAM TECHNOLOGY, INC., having a place of business at Sunnyvale, California, United States of America, (hereinafter called AIBT), desires to acquire the entire right, title and interest of said application and invention, and to any United States and foreign patents to be obtained therefor;

Now therefore, for a valuable consideration, receipt whereof is hereby acknowledged, I, the above named, hereby sell, assign, and transfer to AIBT, its successors and assigns, the entire right, title and interest in the said application and invention therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing said United States application, and I request the Commissioner of Patents to issue any Letters Patent granted upon the inventions set forth in said application to AIBT its successors and assigns; and I hereby agree that AIBT may apply for foreign Letters Patent on said invention and I will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by

CITY AND DATE Signed and Sealed at 116 S. Walfe Rd, Sunnyvale, CA on April 22 2002.

SIGNATURE OF INVENTOR

**RECORDED: 04/26/2002** 

PATENT REEL: 012845 FRAME: 0961